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Title of Invention : METHOD FOR MEASURING A SURFACE PLASMON RESONANCE AND NOBLE METAL COMPOUND USED FOR THE SAME

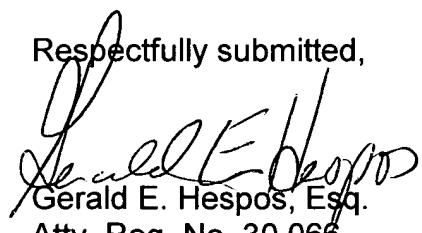
MS PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement includes a copy of Form PTO-1449 that identifies seven Japanese references and one WIPO publication. Copies of the references are attached as well. These references were identified as being relevant in the International Search Report, a copy of which is submitted concurrently with this Information Disclosure Statement. The Examiner is requested to consider these references during the examination and to make the references of record.

Respectfully submitted,



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